

Cambridge University Press
978-1-107-40914-9 - Materials Research Society Symposium Proceedings: Volume 829:
Progress in Compound Semiconductor Materials IV—Electronic and Optoelectronic Applications
Editors: Gail J. Brown, Robert M. Biefeld, Claire Gmachl, M. Omar Manasreh and Karl Unterrainer
Copyright Information
More information

MATERIALS RESEARCH SOCIETY SYMPOSIUM PROCEEDINGS VOLUME 829

Progress in Compound Semiconductor Materials IV— Electronic and Optoelectronic Applications

Symposium held November 29-December 3, 2004, Boston, Massachusetts, U.S.A.

EDITORS:

Gail J. Brown

AFRL/MLPS, Materials and Manufacturing Directorate Wright Patterson Air Force Base, Ohio, U.S.A.

Robert M. Biefeld

Sandia National Laboratories Albuquerque, New Mexico, U.S.A.

Claire Gmachl

Princeton University Princeton, New Jersey, U.S.A.

M. Omar Manasreh

University of Arkansas Fayetteville, Arkansas, U.S.A.

Karl Unterrainer

Technical University Vienna Vienna, Austria



Materials Research Society Warrendale, Pennsylvania



Cambridge University Press

978-1-107-40914-9 - Materials Research Society Symposium Proceedings: Volume 829: Progress in Compound Semiconductor Materials IV—Electronic and Optoelectronic Applications Editors: Gail J. Brown, Robert M. Biefeld, Claire Gmachl, M. Omar Manasreh and Karl Unterrainer Copyright Information

More information

CAMBRIDGE UNIVERSITY PRESS Cambridge, New York, Melbourne, Madrid, Cape Town, Singapore, São Paulo, Delhi, Mexico City

Cambridge University Press 32 Avenue of the Americas, New York NY 10013-2473, USA

Published in the United States of America by Cambridge University Press, New York

www.cambridge.org
Information on this title: www.cambridge.org/9781107409149

Materials Research Society 506 Keystone Drive, Warrendale, PA 15086 http://www.mrs.org

© Materials Research Society 2005

This publication is in copyright. Subject to statutory exception and to the provisions of relevant collective licensing agreements, no reproduction of any part may take place without the written permission of Cambridge University Press.

This publication has been registered with Copyright Clearance Center, Inc. For further information please contact the Copyright Clearance Center, Salem, Massachusetts.

First published 2005 First paperback edition 2012

Single article reprints from this publication are available through University Microfilms Inc., 300 North Zeeb Road, Ann Arbor, MI 48106

CODEN: MRSPDH

ISBN 978-1-107-40914-9 Paperback

Cambridge University Press has no responsibility for the persistence or accuracy of URLs for external or third-party internet websites referred to in this publication, and does not guarantee that any content on such websites is, or will remain, accurate or appropriate.

Effort sponsored by the Air Force Office of Scientific Research, Air Force Material Command, US AF, under FA9550-04-I-0259. The U.S. Government is authorized to reproduce and distribute reprints for Governmental purposes notwithstanding any copyright notation thereon. The views and conclusions herein are those of the authors and should not be interpreted as necessarily representing the official policies or endorsements, either expressed or implied, of the Air Force Office of Scientific Research or the U.S. Government.